

NOTIFICATION OF CHANGE OF

 APPLICANT
 INVENTORTo : Commissioner of
the Korean Industrial Property Office

International Application No. PCT/KR01/00166

Applicant	Name	Korea Advanced institute of Science and Technology et al.	Residence Reg. No.	Country of Nationality	KR	
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Cause of Change		addition of an applicant				
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	Name	PARK, Su Wom	Residence Reg. No.	Country of Nationality	KR	
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Designated State(s)	all designated States except. the United States of America				
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Address #161, Gajong-dong, Yusong-gu, Daejon, 305-350, Republic of Korea					
Contents of Notifi- cation	Designated State(s)	all designated States except. the United States of America			
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Designated State(s)	the United States of America only				
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Address Department of Electrical Engineering, KAIST, Kusong-Dong, Yusong-Ku, Taejon, 305-701 Republic of Korea					
Designated State(s)	the United States of America only				

Submitted hereby is a notification pursuant to Article 82 of the
Enforcement Regulations of the Patent Law.

Date(day/month/year) February 26, 2002

Agent LEE, Jong Il



* Attached Document(s)

1. A copy of the document(s) substantiating the contents of notification (in case of notification by new applicant)
2. A certified copy of seal impression (in case of notification by new applicant)
3. A copy of the document(s) substantiating the power of attorney, if any

Power of Attorney

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I/We, the understanding, do hereby appoint the above-identified agent as my/our agent to act for me/us in all proceedings concerning the following International Application.

International Application No. : PCT/KR01/00166

Title of Invention :

MULTI-DIMENSIONAL ORTHOGONAL RESOURCE HOPPING
MULTIPLESING COMMUNICATIONS METHOD AND APPARATUS

Dated this 20th of February 2002

Applicant Name : Electrons and Telecommunications Research Institute

Representative : Oh, Gil Rok

Address : #161, Gajang-dong, Yuseong-gu, Daejeon
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ASSIGNMENT

ASSIGNOR :

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PCT INTERNATIONAL PATENT APPLICATION :

PCT International Patent No. : PCT/KR01/00166
PCT International Patent Filing Date : 2001. 02. 06

Title of Invention : Multi-dimensional orthogonal resource hopping multiplexing
Communications method and apparatus

ASSIGNOR assigns the partial right to acquire the patent for said PCT
application to ASSIGNEE.

February 20, 2002

Assignor' Signature :

Korea Advanced Institute of Science and Technology
Hong Chang Sun

